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Tender

Tender for a Wide Bandgap Semiconductor Laser Annealing Tool (WBG-LAT)

Swansea University

F02: Contract notice

Notice identifier: 2021/S 000-013102

Procurement identifier (OCID): ocds-h6vhtk-02ba9f

Published 10 June 2021, 4:54pm

Section I: Contracting authority

I.1) Name and addresses

Swansea University

Procurement - VC's Office, Swansea University, Singleton Park

Swansea

SA2 8PP

Contact

SUE DAVIES

Email

sue.davies@swansea.ac.uk

Telephone

+44 1792295890

Country

United Kingdom

NUTS code

UKL21 - Monmouthshire and Newport

Internet address(es)

Main address

www.swansea.ac.uk

Buyer's address

https://www.sell2wales.gov.wales/search/Search_AuthProfile.aspx?ID=AA0345

I.2) Information about joint procurement

The contract is awarded by a central purchasing body

I.3) Communication

The procurement documents are available for unrestricted and full direct access, free of charge, at

<https://etenderwales.bravosolution.co.uk/web/login.shtml>

Additional information can be obtained from the above-mentioned address

Tenders or requests to participate must be submitted electronically via

<https://etenderwales.bravosolution.co.uk/web/login.shtml>

I.4) Type of the contracting authority

Body governed by public law

I.5) Main activity

Education

Section II: Object

II.1) Scope of the procurement

II.1.1) Title

Tender for a Wide Bandgap Semiconductor Laser Annealing Tool (WBG-LAT)

Reference number

SU152(21)

II.1.2) Main CPV code

- 42300000 - Industrial or laboratory furnaces, incinerators and ovens

II.1.3) Type of contract

Supplies

II.1.4) Short description

The University's new flagship Centre for Integrative Semiconductor Materials (CISM) aims to further stimulate growth in this area by delivering a bespoke, integrated facility for semiconductor research and technology development. Prior to the CISM facility being completed, the University seeks to procure specialist semiconductor processing and characterisation equipment of which the proposed Wide Bandgap Semiconductor Laser Annealing Tool (hereafter the 'WBG-LAT') is a major element

II.1.6) Information about lots

This contract is divided into lots: No

II.2) Description

II.2.3) Place of performance

NUTS codes

- UKL21 - Monmouthshire and Newport

Main site or place of performance

Newport Wafer Fab

II.2.4) Description of the procurement

The University's Centre for Integrative Semiconductor Materials (CISM) will allow state-of-the-art cleanroom and laboratory space to house new fabrication and characterisation equipment.

Prior to CISM's completion, the University seeks to procure the proposed Wide Bandgap Semiconductor Laser Annealing Tool which is due to be located at Swansea University and its industrial partner Newport Wafer Fab.

II.2.5) Award criteria

Price is not the only award criterion and all criteria are stated only in the procurement documents

II.2.7) Duration of the contract, framework agreement or dynamic purchasing system

Duration in months

12

This contract is subject to renewal

No

II.2.10) Information about variants

Variants will be accepted: No

II.2.11) Information about options

Options: No

II.2.13) Information about European Union Funds

The procurement is related to a project and/or programme financed by European Union funds: Yes

Identification of the project

Driving the Electric Revolution (DER)

Section III. Legal, economic, financial and technical information

III.1) Conditions for participation

III.1.2) Economic and financial standing

Selection criteria as stated in the procurement documents

III.1.3) Technical and professional ability

Selection criteria as stated in the procurement documents

Section IV. Procedure

IV.1) Description

IV.1.1) Type of procedure

Open procedure

IV.1.8) Information about the Government Procurement Agreement (GPA)

The procurement is covered by the Government Procurement Agreement: Yes

IV.2) Administrative information

IV.2.2) Time limit for receipt of tenders or requests to participate

Date

14 July 2021

Local time

12:00pm

IV.2.4) Languages in which tenders or requests to participate may be submitted

English, Welsh

IV.2.6) Minimum time frame during which the tenderer must maintain the tender

Duration in months: 3 (from the date stated for receipt of tender)

IV.2.7) Conditions for opening of tenders

Date

14 July 2021

Local time

12:00pm

Place

etenderwales BravoSolution

Information about authorised persons and opening procedure

Swansea University Procurement team Category Managers

Section VI. Complementary information

VI.1) Information about recurrence

This is a recurrent procurement: No

VI.2) Information about electronic workflows

Electronic ordering will be used

Electronic invoicing will be accepted

Electronic payment will be used

VI.3) Additional information

Since the CISM build currently underway at the University's Bay campus is not due to be completed until 2022, this equipment will be delivered and installed at Newport Wafer Fab, Cardiff Road, Duffryn, Newport NP10 8YJ.

NOTE: The authority is using eTenderwales to carry out this procurement process. To obtain further information record your interest on Sell2Wales at

https://www.sell2wales.gov.wales/search/search_switch.aspx?ID=111055

(WA Ref:111055)

The buyer considers that this contract is suitable for consortia.

VI.4) Procedures for review

VI.4.1) Review body

High Court

Royal Courts of Justice, The Strand

London

WC2A 2LL

Telephone

+44 2079477501

Country

United Kingdom